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PATENT APPLICATION
TECH CENTER 2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Hiroshi INAGAWA et al.

Appln. No.: 10/046,077

Group Art Unit: 2813

Filed: January 16, 2002

Examiner: D. Blum

For: INSULATED GATE TYPE SEMICONDUCTOR DEVICE AND METHOD
FOR FABRICATING THE SAME

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AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated November 24,
2003, please amend the above-identified patent application
as indicated below.

Amendments to the claims begin on page 2 of this
paper.

Remarks begin on page 15 of this paper.